

Image

1765



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/087,510
Applicants : SETHURAMAN JAYASHANKAR ET AL
Filed : March 1, 2002
Title : SINGLE LAYER RESIST LIFT-OFF
PROCESS AND APPARATUS FOR
SUBMICRON STRUCTURES

Group Art Unit : 1765
Examiner : Shamim Ahmed
Docket No. : 011333

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on

this 28th day of October, 2003.

Dea MacDonald
Buchanan Ingersoll, P.C.

ELECTION AND AMENDMENT

Pittsburgh, Pennsylvania 15219

October 28, 2003

Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to Office Action dated September 30, 2003, please amend this application as set forth hereinafter.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begins on page 7 of this paper.